

Docket No.: 265523US26PCT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

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RE: Application Serial No.: 10/523,974
Applicants: Haruhiko FURUYA, et al.
Filing Date: February 8, 2005
For: SEMICONDUCTOR PROCESSING METHOD AND
APPARATUS FOR PROCESSING TARGET
SUBSTRATE
Group Art Unit: 2823
Examiner: MALDONADO, JULIO J.

SIR:

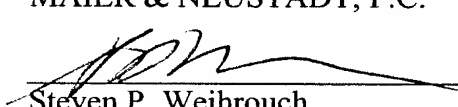
Attached hereto for filing are the following papers:

Response to Restriction Requirement

Our online credit card payment in the amount of **\$0.00** is being made covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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